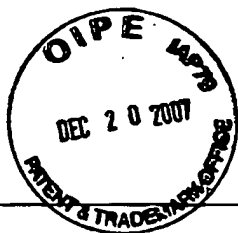


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*Michael S. Huppert*

December 18, 2007

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : Confirmation No. 5135

Atuhito MOCHIDA et al. : Attorney Docket No. 2003\_1798A

Serial No. 10/730,982 : Group Art Unit 1725

Filed December 10, 2003 : Examiner Kiley Shawn Stoner

A METHOD OF MOUNTING A **Mail Stop: AF**

SEMICONDUCTOR LASER

COMPONENT ON A SUBMOUNT

**AMENDMENT AFTER FINAL**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action of September 18, 2007, please amend the above-referenced U.S. patent application as follows: